

Figure 1: UHV STM images of (a) dry contact transferred (DCT) single-wall carbon nanotubes on a Si(100)2x1:H surface¹, and (b) graphene nanostructure on a GaAs(110) surface².

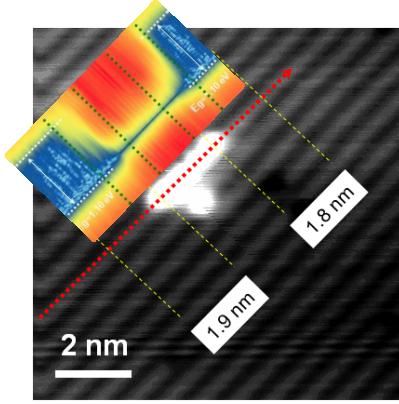


Figure 3: Metallic dangling bond wire (inset: STM spectroscopy) created by STM lithography on a Si(100)2x1:H surface⁴.

References

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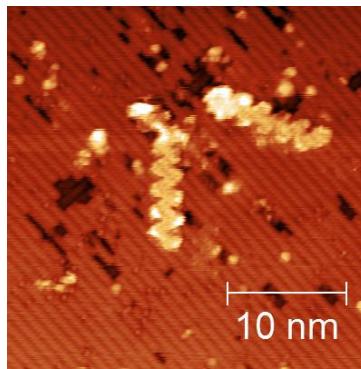


Figure 2: STM image of DCT chevron graphene nanoribbons on a Si(100)2x1:H surface³.

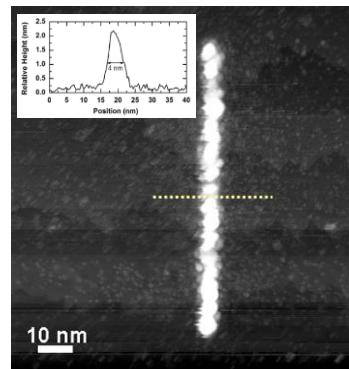


Figure 4: STM images of metallic hafnium diboride wire and dots on Si(100)2x1:H surfaces⁵.

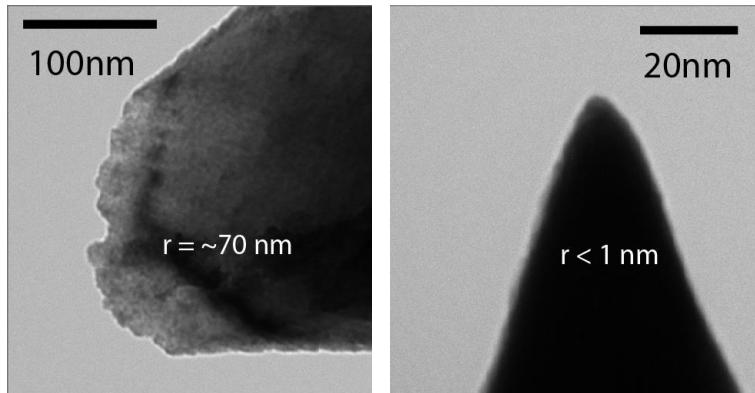


Figure 5: TEM images of a tungsten STM probe before (left) and after (right) field-directed sputter sharpening⁶.